

[図1]

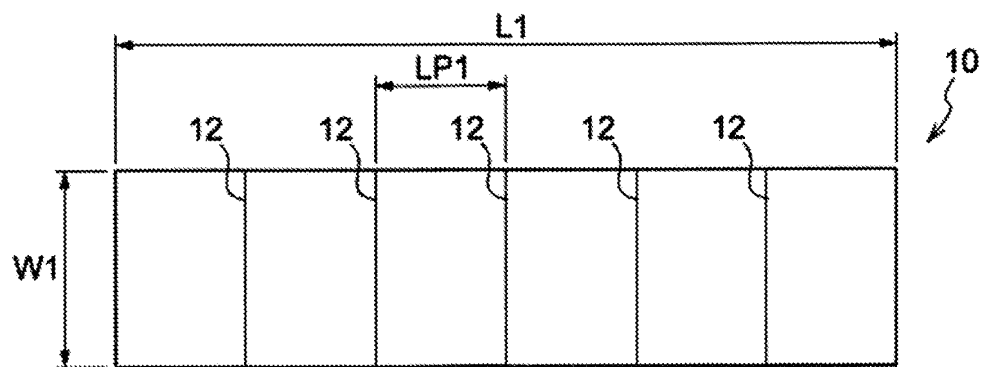


FIG. 1

[図2]

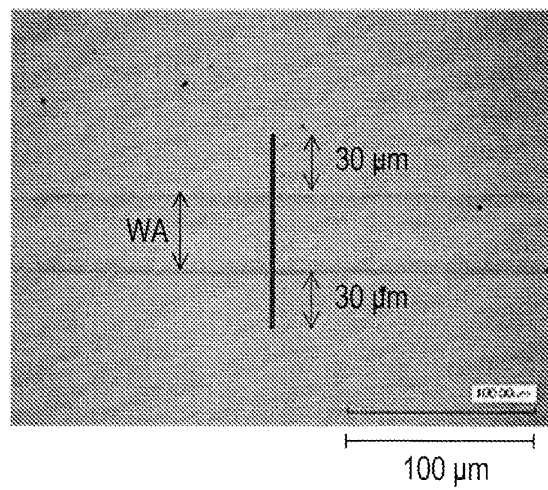


FIG. 2

[図3]

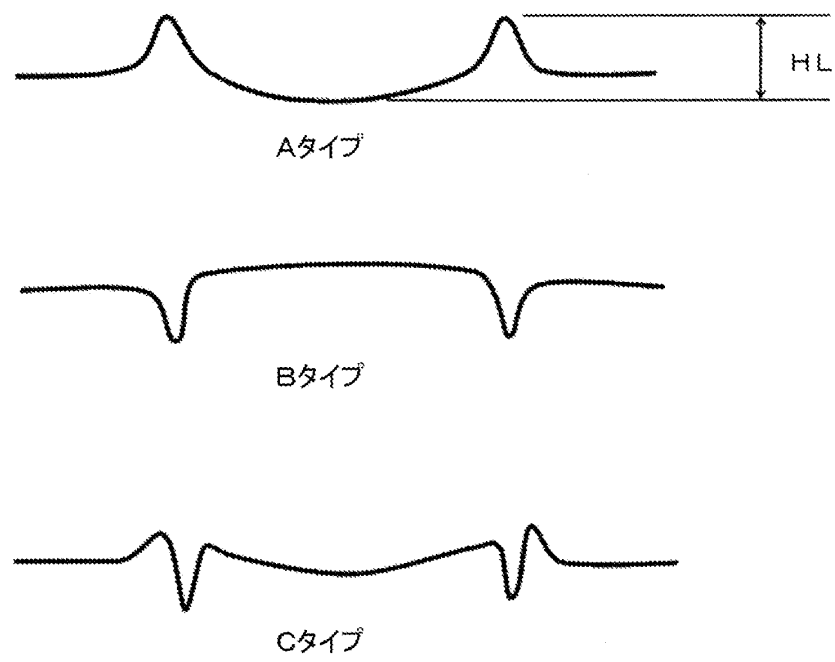


FIG. 3

[図4]

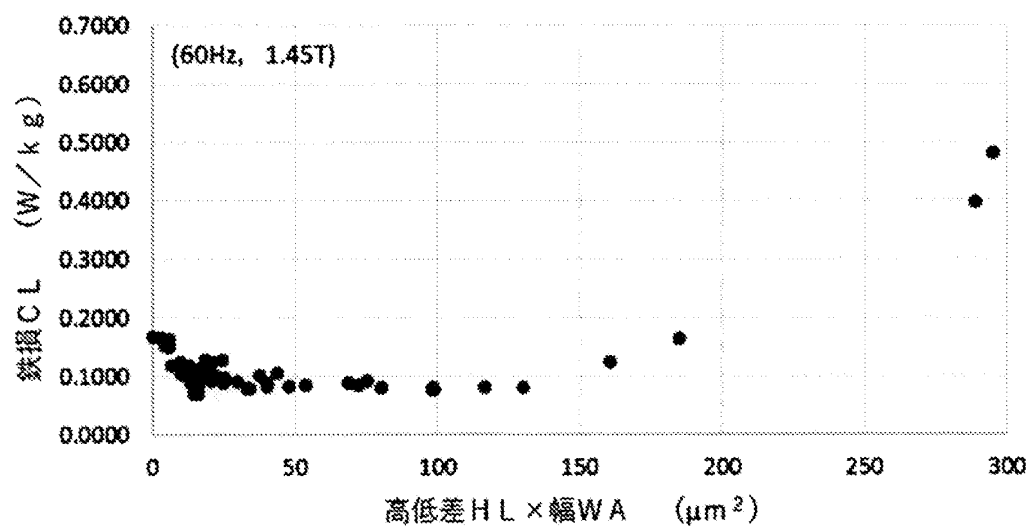


FIG. 4

[図5]

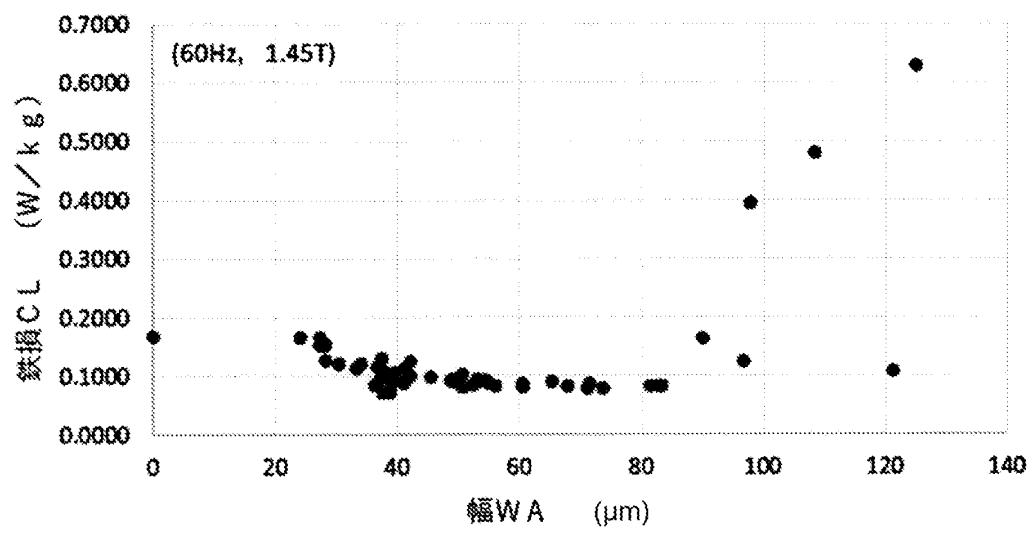


FIG. 5

[図6]

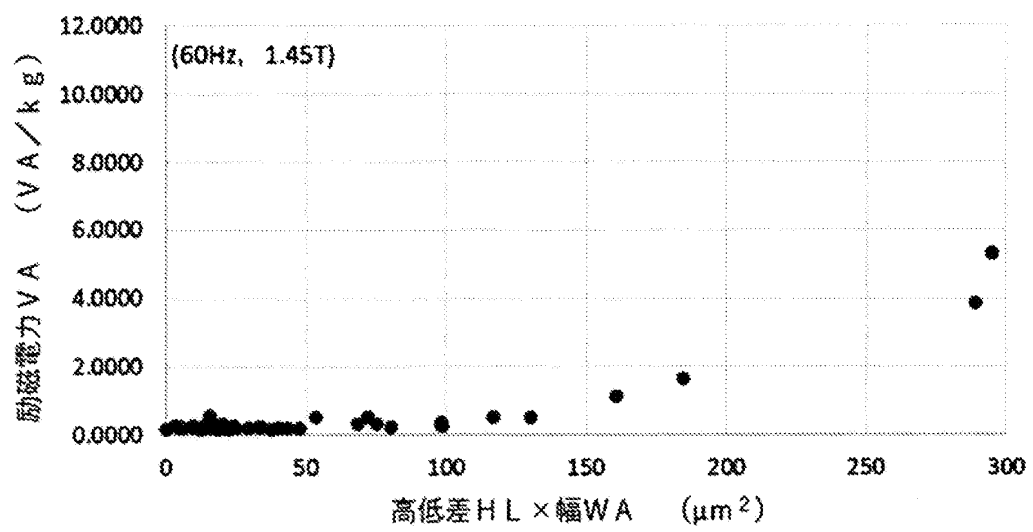


FIG. 6

[図7]

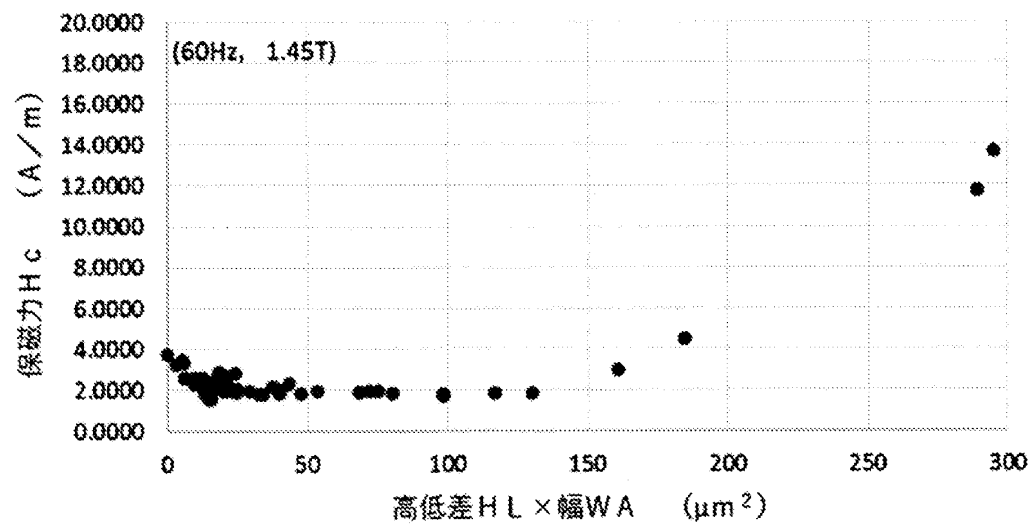


FIG. 7

[図8]

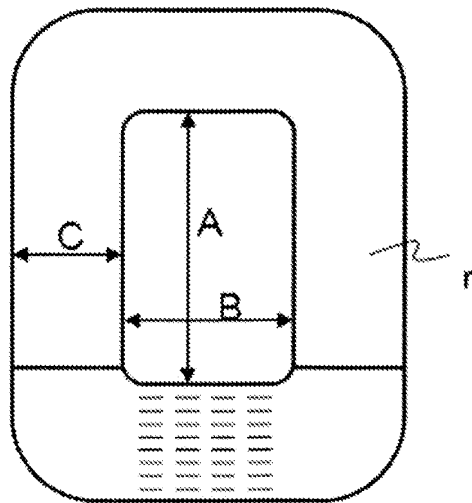


FIG. 8

[図9]

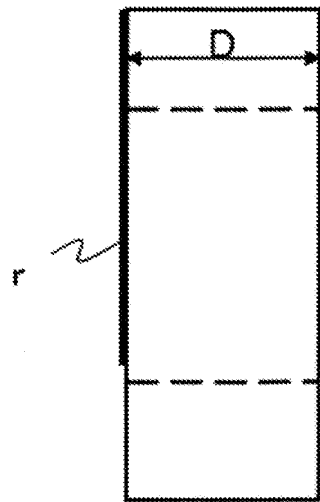


FIG. 9

[図10]

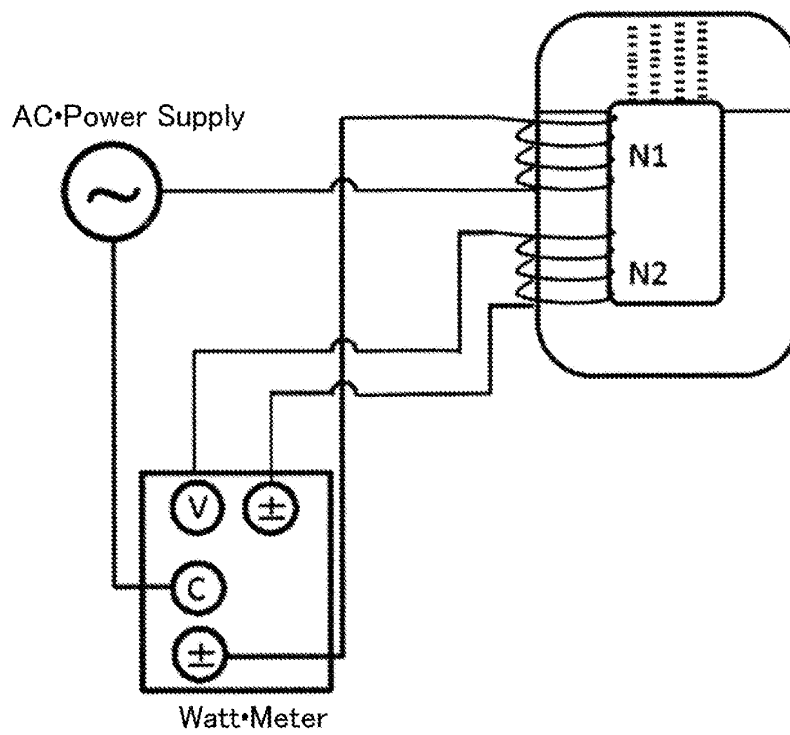


FIG. 10

[図11]

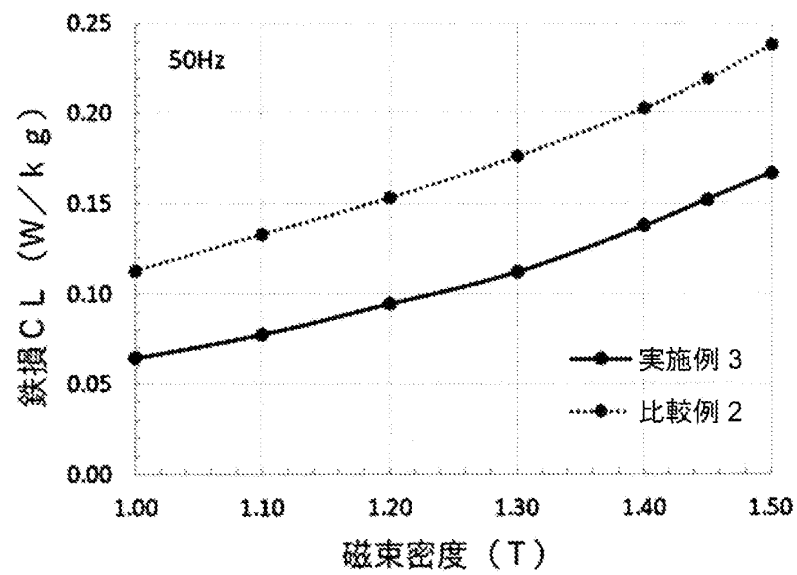


FIG. 11

[図12]

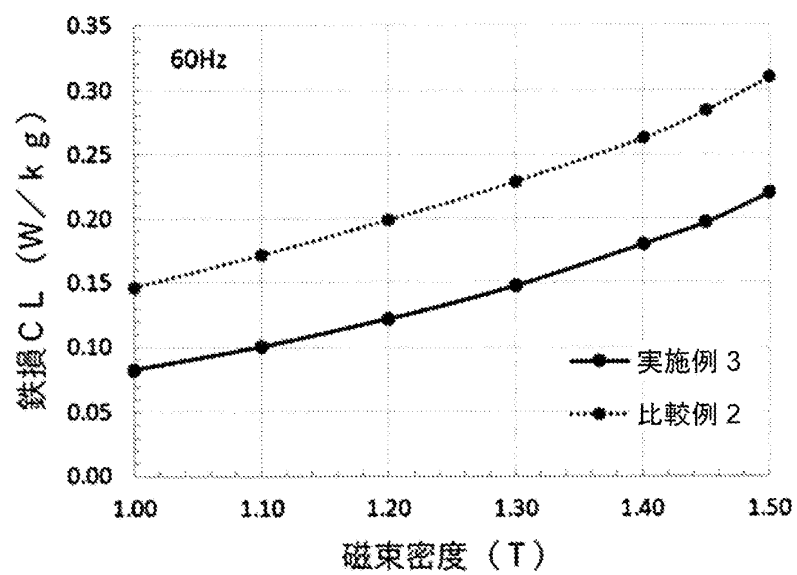


FIG. 12

[図13]

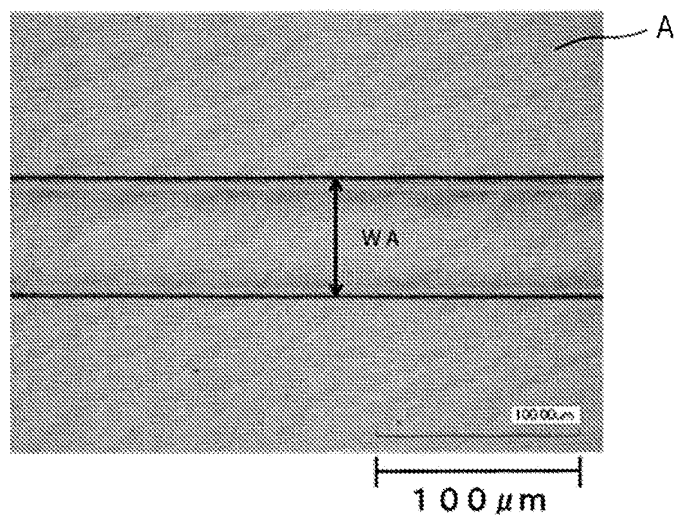


FIG. 13

[図14]

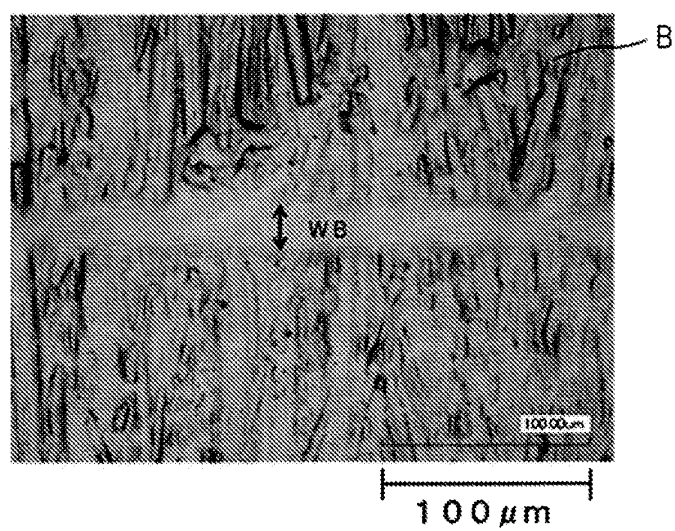


FIG. 14

[図15]

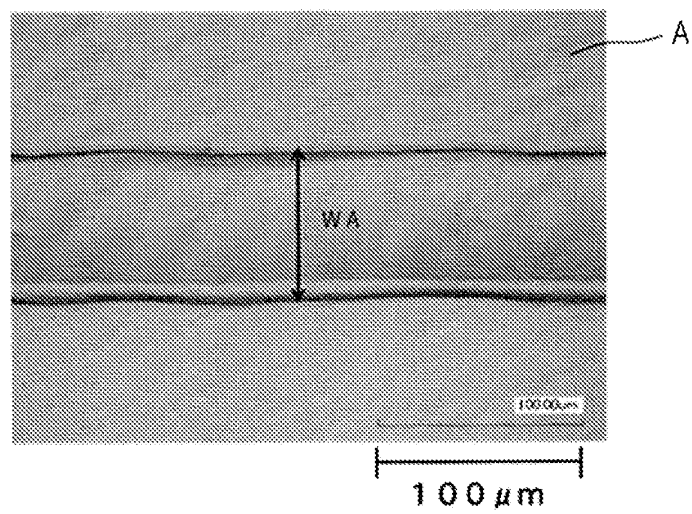


FIG. 15

[図16]

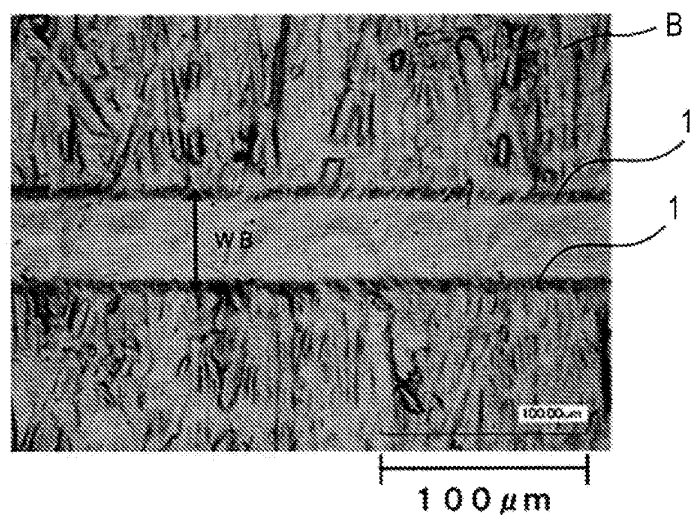


FIG. 16

[図17]

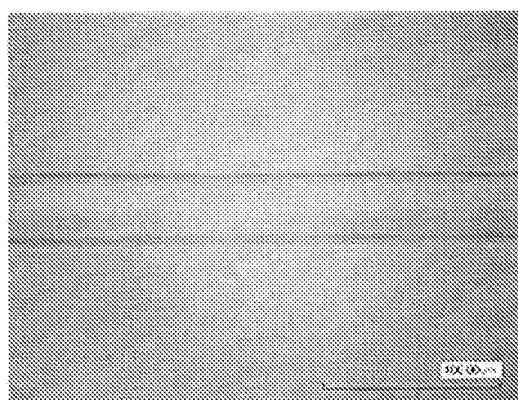


FIG. 17A

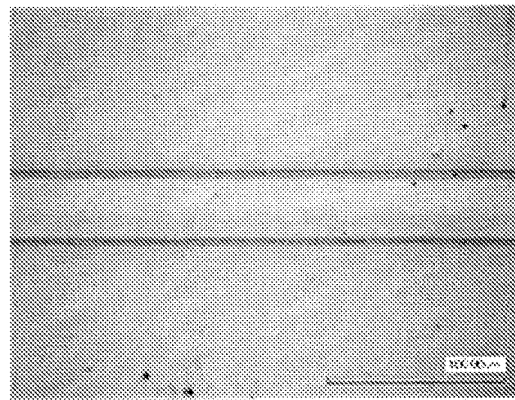


FIG. 17B

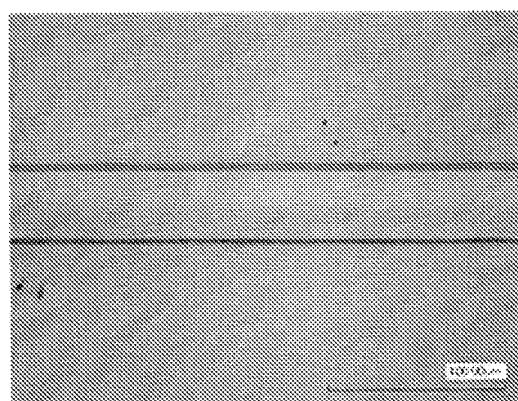


FIG. 17C

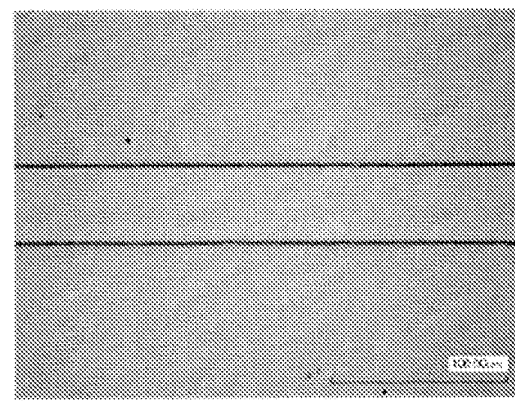


FIG. 17D

[図18]

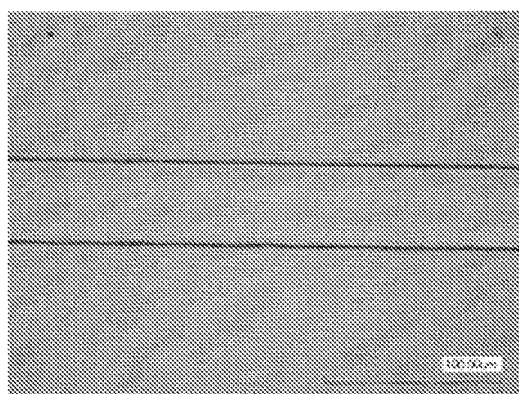


FIG. 18A

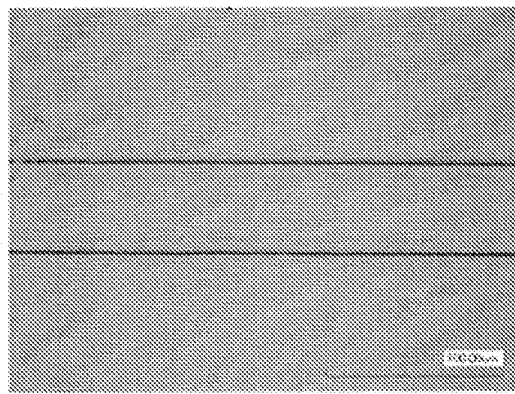


FIG. 18B

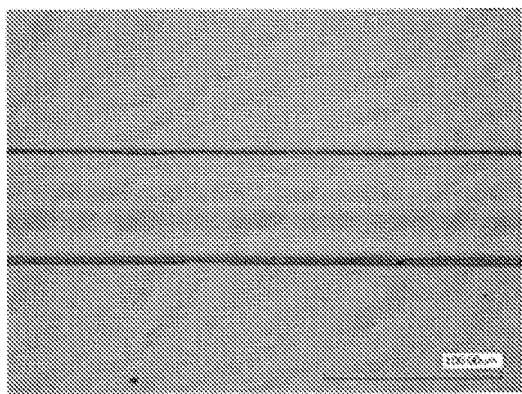


FIG. 18C

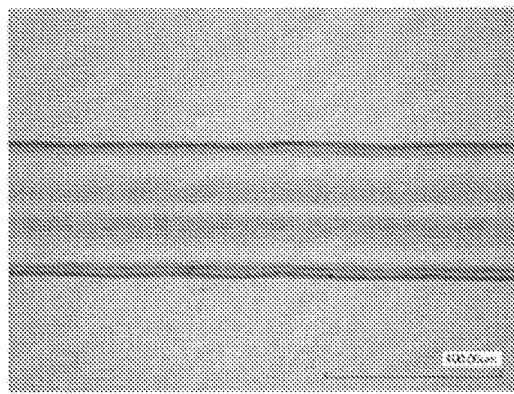


FIG. 18D

[図19]

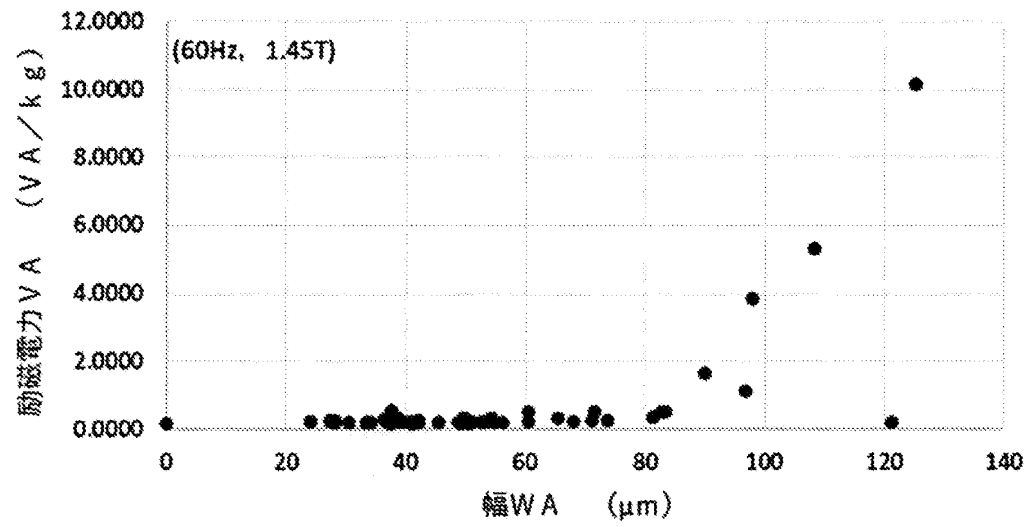


FIG. 19

[図20]

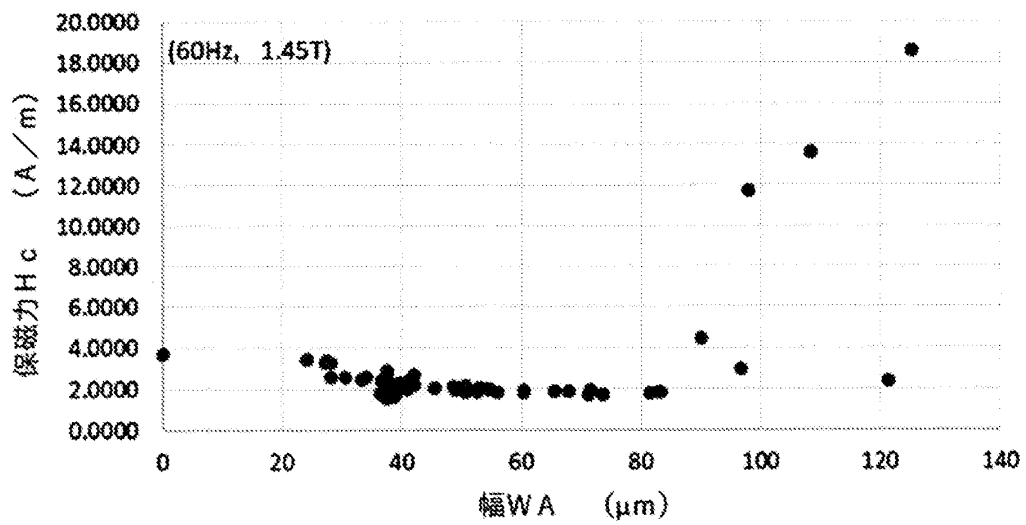


FIG. 20

[図21]

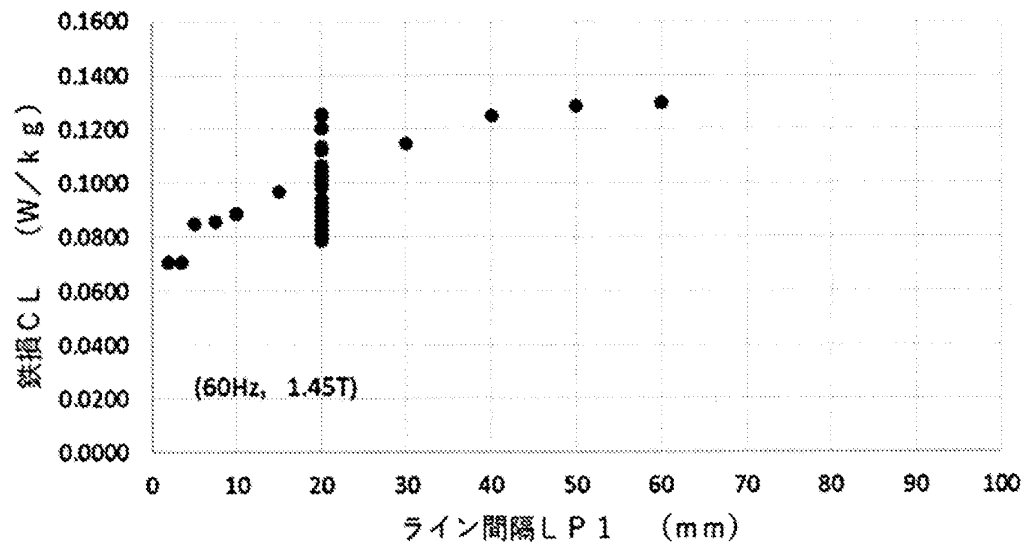


FIG. 21

[図22]

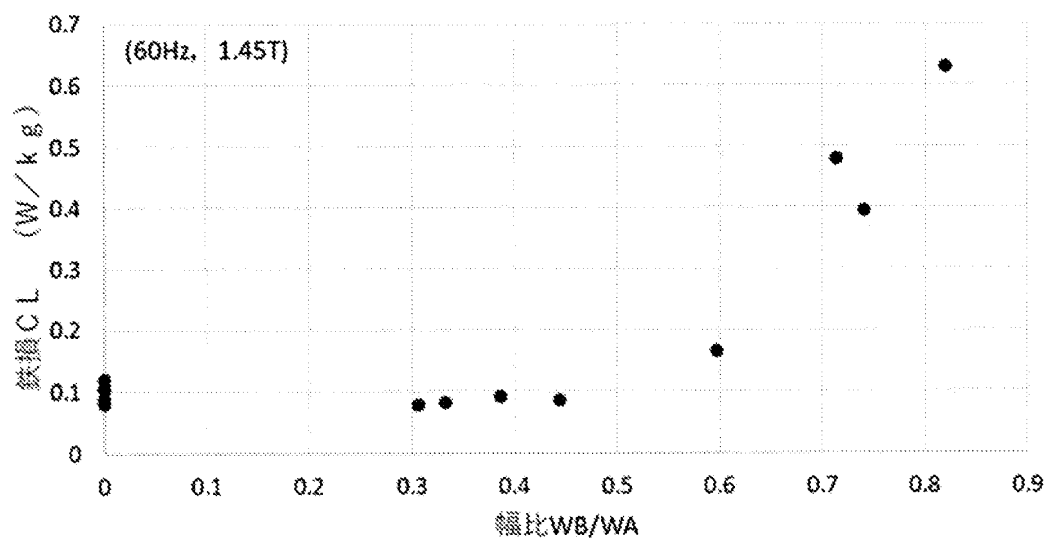


FIG. 22

[図23]

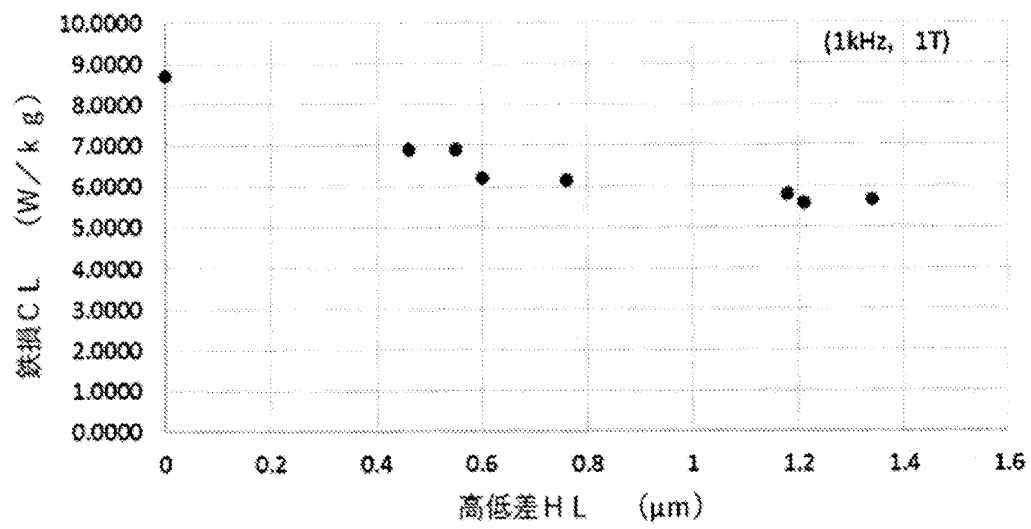


FIG. 23

[図24]

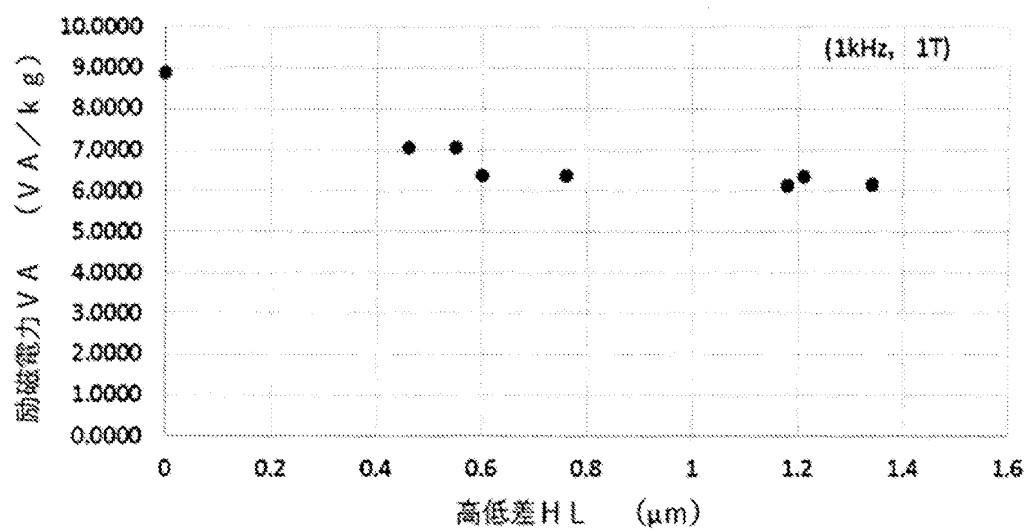


FIG. 24

[図25]

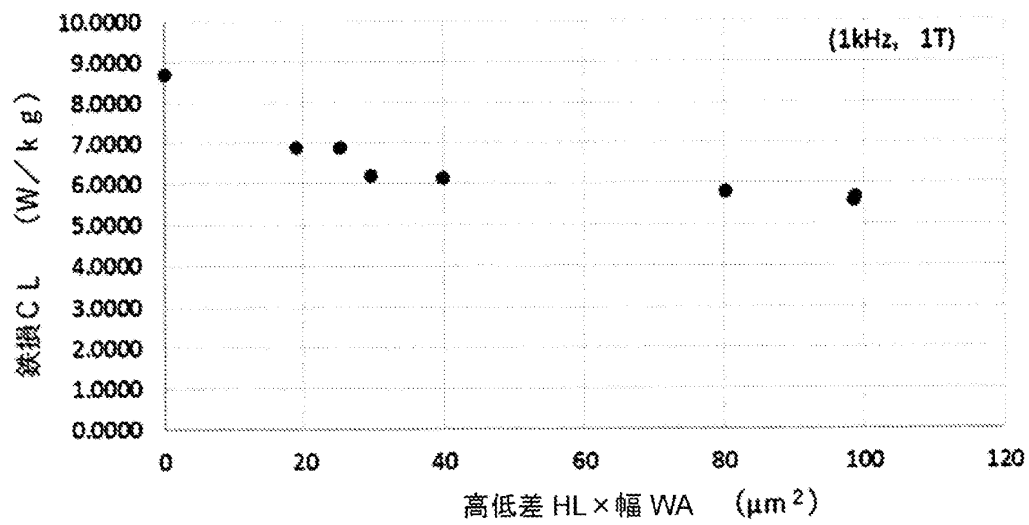


FIG. 25

[図26]

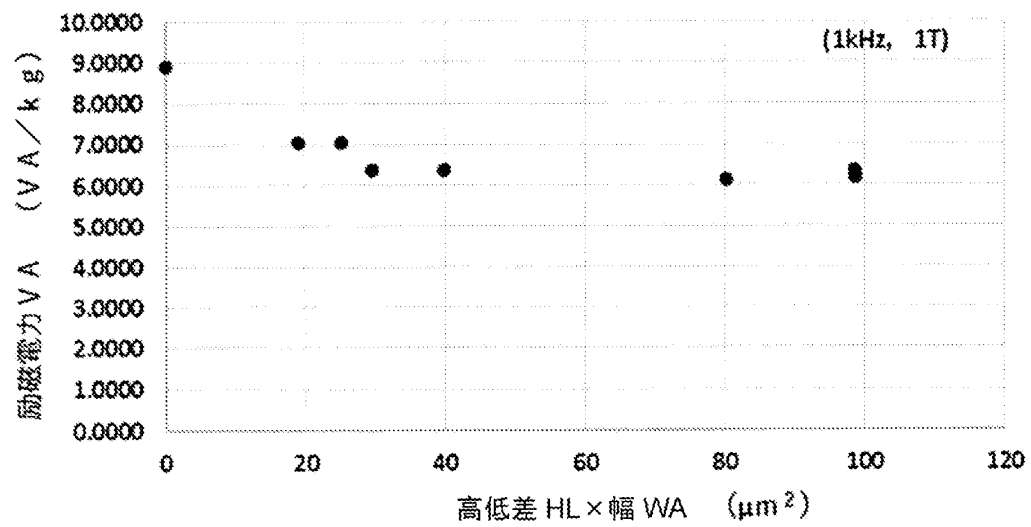


FIG. 26

[図27]

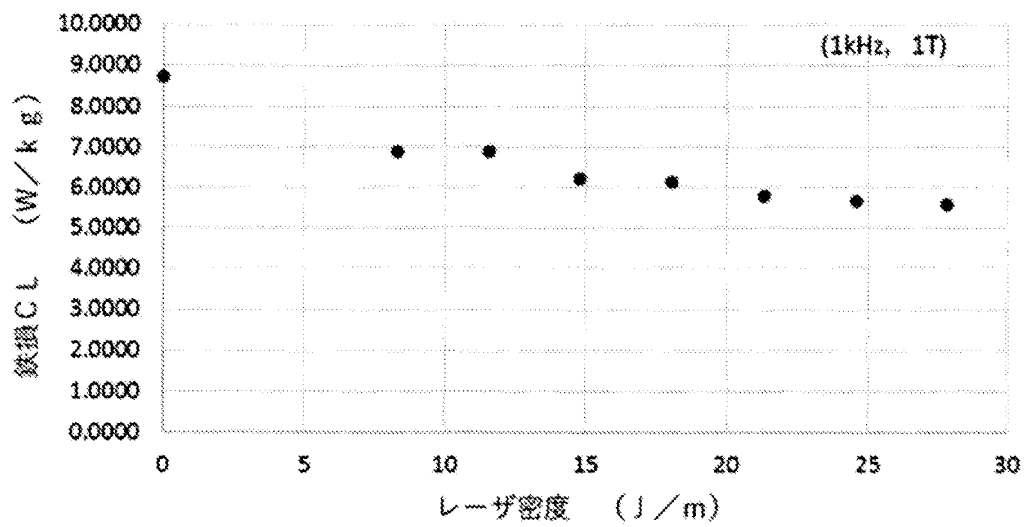


FIG. 27

[図28]

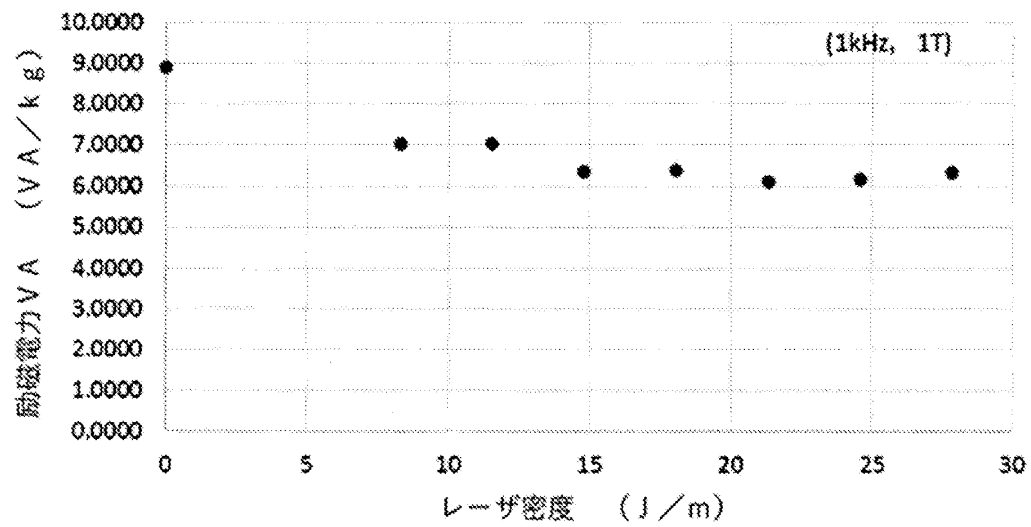


FIG. 28

[図29]

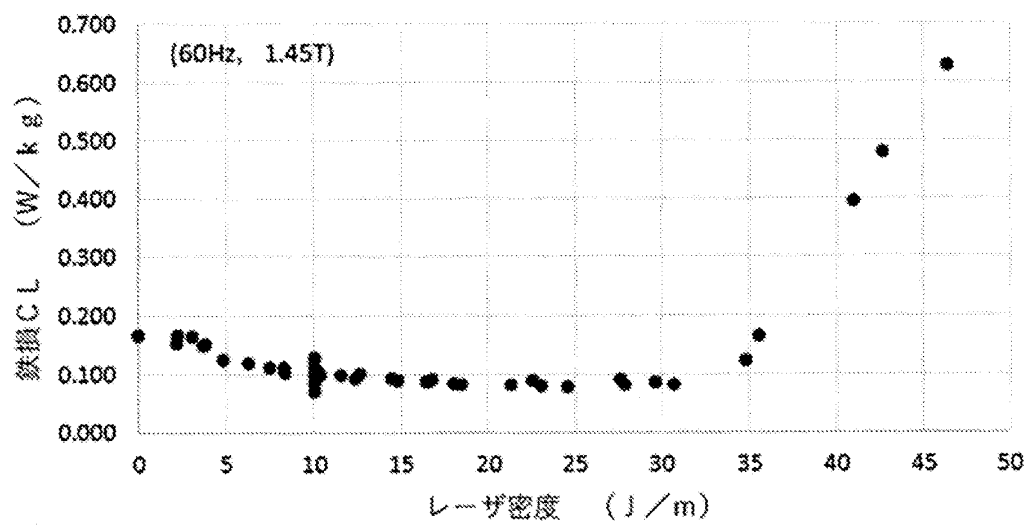


FIG. 29

[図30]

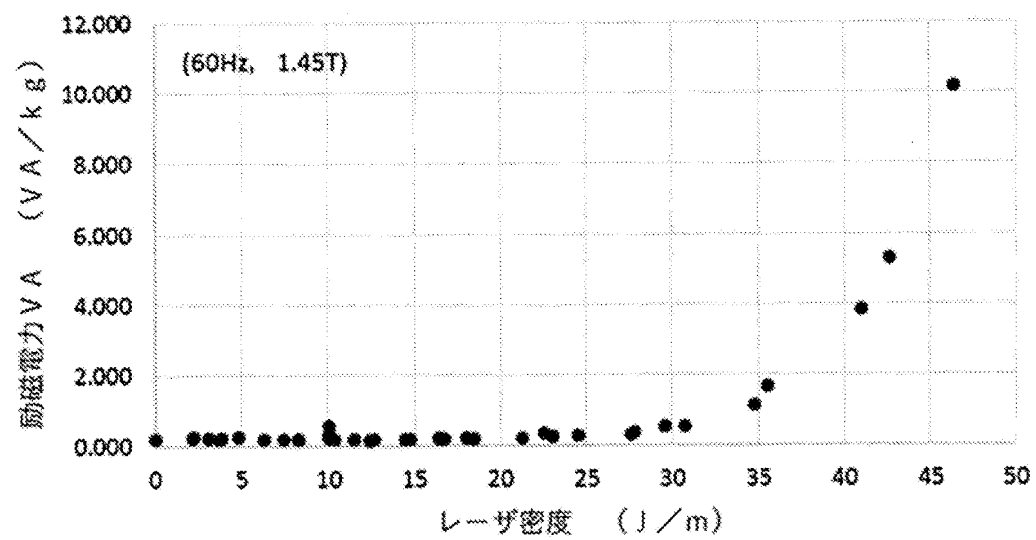


FIG. 30

[図31]

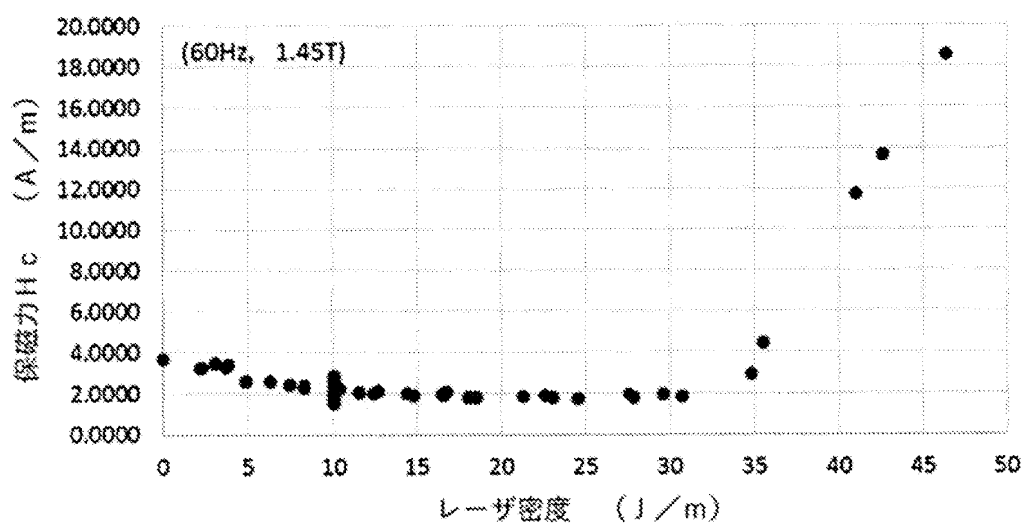


FIG. 31

[図32]

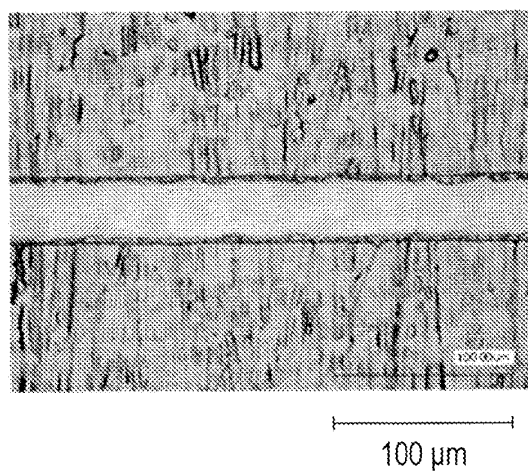


FIG. 32

[図33]

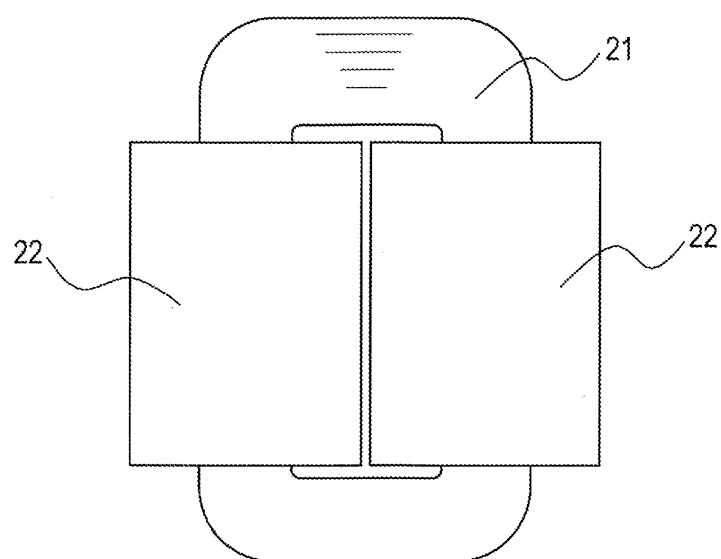


FIG. 33

[図34]

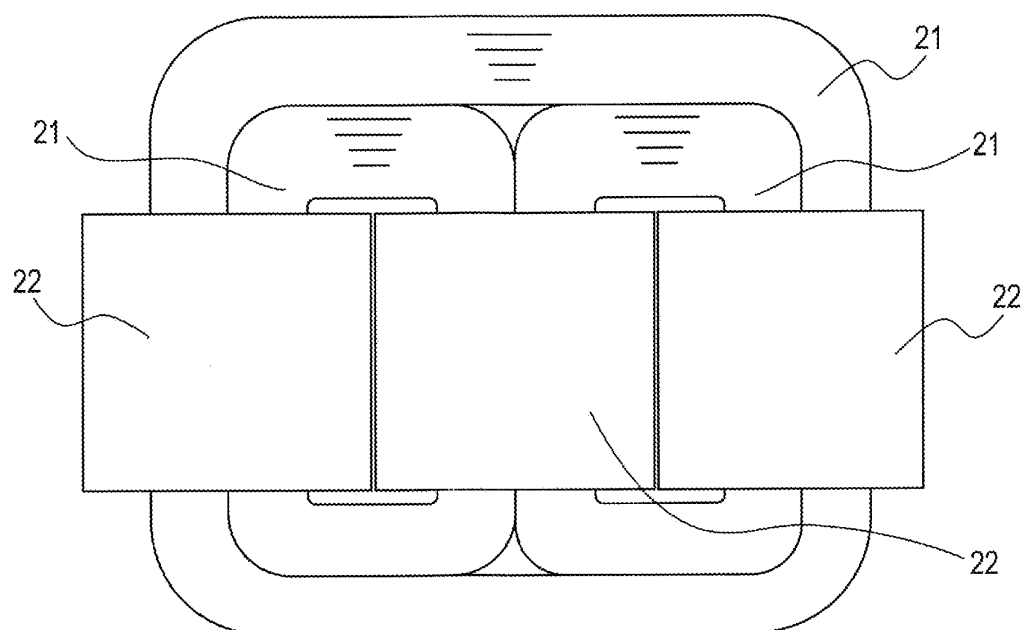


FIG. 34

[図35]

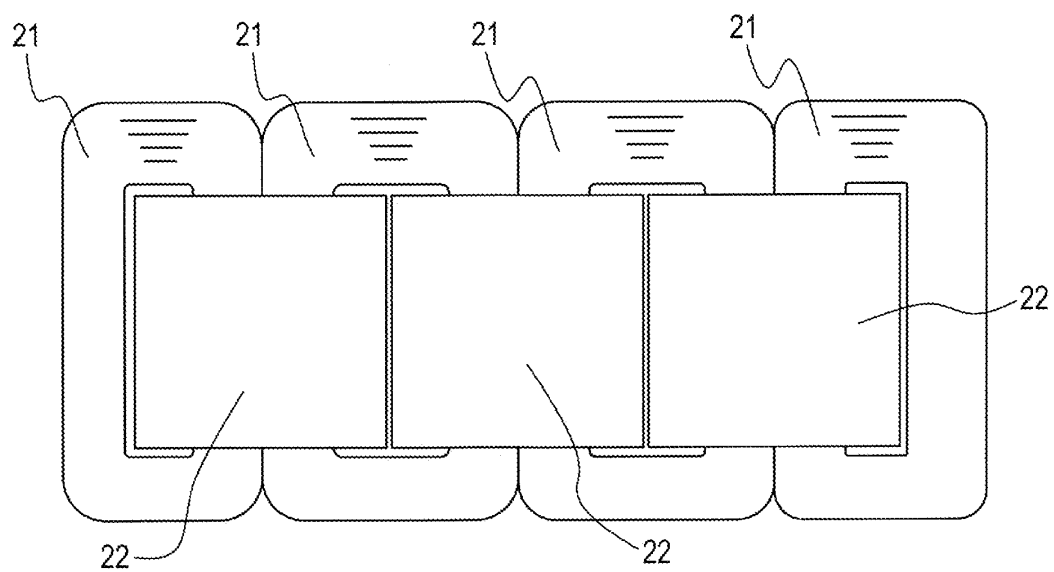


FIG. 35